

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Sung Soo Si et al. Art Unit : 1792
Serial No. : 10/595,203 Examiner : DHINGRA, RAKESH K.
Filed : March 23, 2006 Action Date : January 6, 2009
Title : PLASMA RAPID THERMAL PROCESS APPARATUS IN WHICH
SUPPLY PART OF RADICAL SOURCE IS IMPROVED

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Commissioner for Patents
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AMENDMENT

Dear Examiner:

In response to the Final Office Action of January 6, 2009, please amend the above-referenced application as follows.

Amendment to Claims begins on page 2 of this paper.

Remarks begin on page 5 of this paper submission.

Request of Continued Examination attached to the end of this submission.

*The Commissioner is hereby authorized to charge fees, if any,
or credit any overpayment to Deposit Account No 50-3566.*